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Inventor application of:

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Bo Gu, et al.

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ULTRA FAST LASERS

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**STATUS INQUIRY**

Commissioner for Patents  
U.S. Patent & Trademark Office  
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Sir:

Please inform us of the status of the above-identified patent application and as to when we may expect an Office Action from the U.S. Patent and Trademark Office.

Respectfully submitted,

Bo Gu, et al.

By:

David R. Syrowik  
Reg. No. 27,956  
Attorney/Agent for Applicant

Date: February 10, 2005

**BROOKS KUSHMAN P.C.**  
1000 Town Center, 22<sup>nd</sup> Floor  
Southfield, MI 48075-1238  
Phone: (248) 358-4400  
Fax: (248) 358-3351

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